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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Hidemitsu NAYA et al.

Serial No: Not assigned

Filed: July 23, 2003

For: **SEMICONDUCTOR MANUFACTURING APPARATUS**

Art Unit: Not assigned

Examiner: Not assigned

**TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT**

Mail Stop PATENT APPLICATION  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

The information disclosure statement submitted herewith is being filed concurrently with the subject application [37 C.F.R. § 1.97(b)] and contains no items of information cited in any communication from a foreign patent office in a counterpart foreign application [37 C.F.R. § 1.97(e)(1)].

If it should be determined that for any reason either an insufficient or excessive fee has been paid, please charge any insufficiency or credit any overpayment necessary to ensure consideration of the information disclosure statement for the above-identified application to Deposit Account No. 50-1314. A copy of this paper is enclosed.

Respectfully submitted,

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FORM PTO-1449		Docket Number (Optional) 83394.0010	Application Number Not assigned			
INFORMATION DISCLOSURE CITATION IN AN APPLICATION		Applicant Hidemitsu NAYA et al.				
(Use several sheets if necessary)		Filing Date July 23, 2003		Group Art Unit Not assigned		
<b>U.S. PATENT DOCUMENTS</b>						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	
<b>FOREIGN PATENT DOCUMENTS</b>						
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION (YES/NO)
	63-208215*	8/29/88	Japan			
	WO 00/29954	5/25/00	PCT			
	WO 00/17769	3/30/00	PCT			
	WO 00/18049	3/30/00	PCT			
	07-307262	11/21/95	Japan			
	2000-164666	6/16/00	Japan			
	2002-132986	5/10/02	Japan			
	11-085326	3/30/99	Japan			
	09-153441	6/10/97	Japan			
	2000-164667	6/16/00	Japan			
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>						
	* U.S. Patent Application No. 09/942,425 filed August 29, 2001 corresponds to Japanese Publication No. 63-208215					
EXAMINER		DATE CONSIDERED				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.						